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PPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
10/710,670	07/28/2004	Chiou-Ping Wu	12778-US-PA	4669
31561	7590 01/31/2005		EXAMINER	
JIANQ CHYUN INTELLECTUAL PROPERTY OFFICE			LEE, CALVIN	
7 FLOOR-1, NO. 100 ROOSEVELT ROAD, SECTION 2 TAIPEI, 100			ART UNIT	PAPER NUMBER
			2818	
TAIWAN			DATE MAILED: 01/31/2005	

Please find below and/or attached an Office communication concerning this application or proceeding.

	Application No.	Applicant(s)			
	10/710,670	WU et al.			
Office Action Summary	Examiner	Art Unit			
	Lee, Calvin	2818			
The MAILING DATE of this communication app Period for Reply	ears on the cover sheet with the c	correspondence address			
A SHORTENED STATUTORY PERIOD FOR REPLY THE MAILING DATE OF THIS COMMUNICATION. - Extensions of time may be available under the provisions of 37 CFR 1.13 after SIX (6) MONTHS from the mailing date of this communication. - If the period for reply specified above is less than thirty (30) days, a reply - If NO period for reply is specified above, the maximum statutory period w - Failure to reply within the set or extended period for reply will, by statute, Any reply received by the Office later than three months after the mailing earned patent term adjustment. See 37 CFR 1.704(b).	6(a). In no event, however, may a reply be tir within the statutory minimum of thirty (30) day ill apply and will expire SIX (6) MONTHS from cause the application to become ABANDONE	mely filed ys will be considered timely. The mailing date of this communication. ED (35 U.S.C. § 133).			
Status					
1) Responsive to communication(s) filed on	_·				
2a) ☐ This action is FINAL . 2b) ∯ This action is non-final.					
3) Since this application is in condition for allowance except for formal matters, prosecution as to the merits is					
closed in accordance with the practice under E	x parte Quayle, 1935 C.D. 11, 4	53 O.G. 213.			
Disposition of Claims		•			
4)⊠ Claim(s) <u>1-11</u> is/are pending in the application.					
4a) Of the above claim(s) is/are withdrawn from consideration.					
5) Claim(s) is/are allowed.					
6) Claim(s) is/are rejected.					
7) Claim(s) is/are objected to.					
8) Claim(s) <u>1-11</u> are subject to restriction and/or e	election requirement.				
Application Papers					
9) The specification is objected to by the Examine	r.				
10) ☐ The drawing(s) filed on is/are: a) ☐ accepted or b) ☐ objected to by the Examiner.					
Applicant may not request that any objection to the					
Replacement drawing sheet(s) including the correction 11) The oath or declaration is objected to by the Ex					
Priority under 35 U.S.C. § 119					
12)⊠ Acknowledgment is made of a claim for foreign priority under 35 U.S.C. § 119(a)-(d) or (f). a)⊠ All b)□ Some * c)□ None of:					
1.⊠ Certified copies of the priority documents have been received.					
2. Certified copies of the priority documents have been received in Application No					
3. Copies of the certified copies of the priority documents have been received in this National Stage					
application from the International Bureau	•				
* See the attached detailed Office action for a list of the certified copies not received.					
Attachment(s)	4) Interview Summary	/ (PTO-413)			
1) Motice of References Cited (PTO-892) 2) Motice of Draftsperson's Patent Drawing Review (PTO-948)	Paper No(s)/Mail D	ate			
3) Information Disclosure Statement(s) (PTO-1449 or PTO/SB/08) Paper No(s)/Mail Date	5) Notice of Informal I	Patent Application (PTO-152)			
S Patent and Trademark Office					

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Application No: 10/710,670

Docket: 12778-US-PA

OFFICE ACTION

Election/Restriction

1. Claims 1-11 are pending in this application.

Restriction to one of the following inventions is required under 35 U.S.C. 121:

- (I) Claims 1-7, drawn to an auto-recovery wafer testing method [class 438, subclass 14];
- (II) Claims 8-11, drawn to an auto-recovery wafer testing apparatus [class 324, subclass 765].
- 2. Inventions I and II are related as process for its practice and apparatus. The inventions are distinct if it can be shown that either: (1) the process as claimed can be practiced by another materially different apparatus or by hand, or (2) the apparatus as claimed can be used to practice another and materially different process. See MPEP § 806.05(e).

In this case: (Group II compared to Group I) the auto-recovery wafer testing apparatus comprised of a tester coupled to a main system, and a real-time accessing module, reveals totally different compared to the method of testing a wafer comprising first and second testing steps.

3. Applicant is advised that the reply to this requirement to be completed must include an election of the invention to be examined even though the requirement is traversed (37CFR 1.143)

Contact Information

4. Any inquiry concerning this communication from the Examiner should be directed to Calvin Lee at (571) 272-1896 from 7:00AM to 5:00PM (Monday-Thursday, Eastern Time). If attempts to reach the examiner by telephone are unsuccessful, Art Unit 2825's Supervisory Patent Examiner David C. Nelms can be reached at (571) 272-1787.

Any inquiry relating to the status of this application should be directed to the Group receptionist whose telephone number is (703) 308-0596. The central fax number is (703) 872-9306 for all communications to be entered (e.g., amendments, remarks, IDS, etc.)

January 31, 2005